



## APPLICATION DATA SHEET

Electronic Version v14

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<b>Title of Invention</b>	METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER CRYSTALLIZATION PROCESS		
Application Type : regular, utility Attorney Docket Number : ADTP0068USA			
Correspondence address: Customer Number: 027765			
			
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Inventor Information: <u>Inventor 1:</u> <b>Applicant Authority Type:</b> Inventor <b>Citizenship:</b> TW <b>Given Name:</b> Kun-Chih <b>Family Name:</b> Lin <b>Residence:</b> <b>City of Residence:</b> Hsin-Chu Hsien <b>Country of Residence:</b> TW <b>Address-1 of Mailing Address:</b> 6F, No. 5, Lane 378, Sec. 2, Chung-Hsing Rd., <b>Address-2 of Mailing Address:</b> Chu-Tung Town <b>City of Mailing Address:</b> Hsin-Chu Hsien <b>State of Mailing Address:</b> <b>Postal Code of Mailing Address:</b> <b>Country of Mailing Address:</b> TW <b>Phone:</b> <b>Fax:</b> <b>E-mail:</b>			
Attorney Information: practitioner(s) at Customer Number: 027765			
			

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